Notice of Allowability	Application No.	Applicant(s)
	10/050,299	BAHNS ET AL.
	Examiner	Art Unit
	Melvin Curtis Mayes	1734
The MAILING DATE of this communication appearance All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this ap or other appropriate communication IGHTS. This application is subject to	plication. If not included will be mailed in due course. THIS
1. This communication is responsive to <u>amendment field 5/23</u>	<u>3/05</u> .	·
2. The allowed claim(s) is/are 1-3 and 5-22.		
3. \boxtimes The drawings filed on <u>18 January 2002</u> are accepted by th	e Examiner.	
4. ☐ Acknowledgment is made of a claim for foreign priority ur a) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents have 2. ☐ Certified copies of the priority documents have 3. ☐ Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received:	e been received. e been received in Application No cuments have been received in this	national stage application from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a reply IENT of this application.	complying with the requirements
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give	itted. Note the attached EXAMINER es reason(s) why the oath or declara	'S AMENDMENT or NOTICE OF ation is deficient.
 CORRECTED DRAWINGS (as "replacement sheets") must (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date 	son's Patent Drawing Review (PTO-	
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t	.84(c)) should be written on the drawi he header according to 37 CFR 1.121(ngs in the front (not the back) of d).
7. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT	sit of BIOLOGICAL MATERIAL I FOR THE DEPOSIT OF BIOLOGIC	must be submitted. Note the AL MATERIAL.
Adda a la una cuerdo N		
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5. Notice of Informal F	atent Application (PTO-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. 🛛 Interview Summary	(PTO-413),
Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date	Paper No./Mail Da 98), 7. ⊠ Examiner's Amendr	
Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. ⊠ Examiner's Stateme	ent of Reasons for Allowance Melvin Curtisumayes Primary Examiner
		Art Unit: 1734
U.S. Patent and Trademark Office PTOL-37 (Rev. 1-04) No	otice of Allowability	Part of Paper No./Mail Date 20050801

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EXAMINER'S AMENDMENT

(1)

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Eric Levinson on July 28, 2005.

The application has been amended as follows:

Claims 1 and 2 have been rewritten to read:

1. A method comprising:

creating a first generation check disk from a master without destroying the master; testing the check disk; and

creating a first generation stamper from the master when the check disk is acceptable, wherein creating the first generation check disk comprises:

coating a master surface with a release layer;

coating a photopolymer layer on a check disk substrate;

contacting the photopolymer layer with the release layer;

curing the photopolymer layer to bond the photopolymer layer to the check disk substrate and to preserve a pattern of the master surface in the photopolymer layer;

separating the photopolymer layer from the release layer; and

depositing at least one of the following on the photopolymer layer: a reflective material, a phase change material and a magneto-optic material.

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2. A method comprising:

creating a first generation check disk directly from a master without destroying the master and prior to creating a first-generation stamper;

delivering the check disk to a customer; and

creating the first generation stamper from the master when the customer indicates acceptance of the check disk.

Claim 4 has been cancelled:

Specification, page 5, line 23, after "2001," the phrase "now U.S. Patent No. 6,638,692," has been inserted;

Specification, page 5, line 29, after "09/906,357," the phrase ", now U.S. Patent No. 6,638,692," has been inserted;

Specification, page 14, line 17, after "2001" the phrase ", now U.S. Patent No. 6,616,867," has been inserted;

Specification, page 14, line 21, after "09/778,482" the phrase ", now U.S. Patent No. 6,616,867," has been inserted.

(2)

The following is an examiner's statement of reasons for allowance: The closest prior art of record, Henmi et al. 5,274,618 and Hirono et al. 6,635,896, disclose testing a first generation stamper made from a master. The prior art of record does not disclose or suggest creating a first generation check disk from a master by the steps as claimed in Claims 1 and 20 and testing the check disk before a first generation stamper is created from the master, or as claimed in Claim 2 made directly from the master and prior to

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creating a first generation stamper and delivered to a customer before the first generation stamper is created from the master.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

(3)

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Melvin Curtis Mayes whose telephone number is 571-272-1234. The examiner can normally be reached on Mon-Fri 7:30 AM - 4:00 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Chris Fiorilla can be reached on 571-272-1187. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you

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have questions on access to the Private PAIR system, contact the Electronic Business

Center (EBC) at 866-217-9197 (toll-free).

Melvin Curtis Mayes Primary Examiner Art Unit 1734

MCM August 1, 2005